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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*

*Name WLL*

## \*\* FOREIGN APPLICATIONS \*\*\*

*Name WLL*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>WLL</i> Examiner's Signature Initials	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 2	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
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## TITLE

Method for manufacturing a semiconductor device having an improved disposable spacer

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